

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 09/755,673
Filing Date January 5, 2001
Inventor Forbes et al.
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner K.D. Nguyen
Attorney Docket No. MI22-1531
Title: Methods of Forming Capacitor Structures, and Capacitor Structures

Assistant Commissioner for Patents
Washington, D.C. 20231

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9318 on the date shown below:

1. Response to August 28, 2002 Office Action
2. Version with Markings to Show Changes Made

FAX RECEIVED

NOV 08 2002

TECHNOLOGY CENTER 2800

Dated: November 8 2002By: J. Gaines

Jennifer Gaines, Legal Assistant
Telephone No. (509) 624-4276

NUMBER OF PAGES IN FACSIMILE: 5

Appl. No. 09/755,673

*6/Response
T. Steptoe
11-15-02***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No.09/755,673
Filing Date1/5/2001
Inventor.....Forbes et al.
Assignee.....Micron Technology, Inc.
Group Art Unit.....2823
Examiner Nguyen, K.D.
Attorney's Docket No.MI22-1531
Title: Methods of Forming Capacitor Structures, and Capacitor Structures

RESPONSE TO AUGUST 28, 2002 OFFICE ACTION

To: Box NON FEE Amendment, VIA FAX: 703-872-9318
Assistant Commissioner for Patents
Washington, D.C. 20231

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS**Amendments to Claims**

None.

FAX RECEIVED

NOV 08 2002

TECHNOLOGY CENTER 2800